IRW



n re application of

Confirmation No. 8571

Kenji SAWAMURA

Docket No. 2003_0942

Serial No. 10/614,781

Group Art Unit 2815

Filed July 9, 2003

Examiner Jesse A. Penty

SEMICONDUCTOR DEVICE HAVING A DUMMY ACTIVE REGION FOR CONTROLLING HIGH DENSITY PLASMA CHEMICAL VAPOR DEPOSITION

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

Sir:

In response to the Office Action of March 29, 2004, please amend the above-identified U.S. Patent application as follows: